

Search Notes 	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/658,840	DAMMEL ET AL.
	Examiner John S. Chu	Art Unit 1752

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
430	270.1,905	9/20/66	JAS
430	907,910	1	L